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Practitioner's Docket No.: 081468-0306007  
Client Reference No.: P-1556.010-US

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Confirmation No:  
VAN HAREN et al.  
Application No.: TO BE ASSIGNED Group No.:  
Filed: September 22, 2003 Examiner:  
For: A MARKER STRUCTURE FOR OPTICAL ALIGNMENT OF A SUBSTRATE,  
A SUBSTRATE INCLUDING SUCH A MARKER STRUCTURE, AN  
ALIGNMENT METHOD FOR ALIGNING TO SUCH A MARKER  
SUBSTRATE, AND A LITHOGRAPHIC PROJECTION APPARATUS

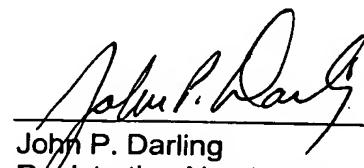
**Commissioner for Patents**  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUBMISSION OF PRIORITY DOCUMENT**

Attached please find the certified copy of the foreign application from which priority is claimed for this case:

<u>Country</u>	<u>Application Number</u>	<u>Filing Date</u>
EUROPE	03076422.9	05/12/2003

Date: September 22, 2003  
PILLSBURY WINTHROP LLP  
P.O. Box 10500  
McLean, VA 22102  
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Customer Number: 00909



Europäisches  
Patentamt

European  
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Office européen  
des brevets

**Bescheinigung**

**Certificate**

**Attestation**

Die angehefteten Unterlagen stimmen mit der ursprünglich eingereichten Fassung der auf dem nächsten Blatt bezeichneten europäischen Patentanmeldung überein.

The attached documents are exact copies of the European patent application described on the following page, as originally filed.

Les documents fixés à cette attestation sont conformes à la version initialement déposée de la demande de brevet européen spécifiée à la page suivante.

**Patentanmeldung Nr. Patent application No. Demande de brevet n°**

**03076422.9**

Der Präsident des Europäischen Patentamts:  
Im Auftrag

For the President of the European Patent Office  
Le Président de l'Office européen des brevets  
p.o.

**R C van Dijk**



Anmeldung Nr:  
Application no.: 03076422.9  
Demande no:

Anmeldetag:  
Date of filing: 12.05.03  
Date de dépôt:

Anmelder/Applicant(s)/Demandeur(s):

ASML Netherlands B.V.  
De Run 1110  
5503 LA Veldhoven  
PAYS-BAS

Bezeichnung der Erfindung/Title of the invention/Titre de l'invention:  
(Falls die Bezeichnung der Erfindung nicht angegeben ist, siehe Beschreibung.  
If no title is shown please refer to the description.  
Si aucun titre n'est indiqué se referer à la description.)

Lithographic marker structure compliant with microelectronic device processing,  
lithographic projection apparatus comprising such a lithographic marker structure  
and method for wafer alignment using such a lithographic marker structure

In Anspruch genommene Priorität(en) / Priority(ies) claimed /Priorité(s)  
revendiquée(s)

Staat/Tag/Aktenzeichen/State/Date/File no./Pays/Date/Numéro de dépôt:

Internationale Patentklassifikation/International Patent Classification/  
Classification internationale des brevets:

G03F/

Am Anmeldetag benannte Vertragstaaten/Contracting states designated at date of  
filling/Etats contractants désignés lors du dépôt:

AT BE BG CH CY CZ DE DK EE ES FI FR GB GR HU IE IT LU MC NL  
PT RO SE SI SK TR LI

03076422.9

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